



# 27/H  
4/10/03  
PATENT APPLICATION  
Do. No. 5484-48  
Shm H

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup SHIM and Young-Ho KIM

Serial No. 09/305,240

Examiner: Nadav, Ori

Filed: May 4, 1999

Group Art Unit: 2811

For: **OPEN DRAIN INPUT/OUTPUT STRUCTURE AND MANUFACTURING  
METHOD THEREOF IN SEMICONDUCTOR DEVICE**

Confirmation No. 1838

BOX RCE  
Assistant Commissioner for Patents  
Washington, D.C. 20231

**REQUEST FOR CONTINUED EXAMINATION**

Responsive to the Final Office Action, dated January 3, 2003, please amend the  
application as follows.